ISSUE CLASSIFICATION PATENT XUMBER Subcton Cha M.S. WITT PAVENT DAVE APPLICATION NO. CONT/PRIOR CLASS SUBCLASS ART UNIT 09/811915 2858 2829 324 Wadgi Abadeer William Motsiff Edward Nowak Wafer level system for producing burn-in/screen, and reliability evaluations to be performed on all chips simultaneously without any wafer contacting 1 0 ۵۵۵۵ کی دست سنعاضک لالایت با W. B. W. W.

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